



Attorney's Docket No.: 096790P372

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application for:

Masayuki Yoneda, et al.

Application No.: 09/913,779

Filed: January 10, 2002

For: SEMICONDUCTOR PRESSURE SENSOR

Examiner: Oen, William L.

Art Group: 2855

Confirmation No.: 4002

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

Dear Commissioner:

In connection with the Office Action mailed August 13, 2003 regarding the above-referenced application, Applicants respectfully request consideration of the following remarks below.

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TECHNOLOGY CENTER 2800